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SERIAL NUMBER 10/691,108	FILING DATE 10/22/2003  RULE	CLASS 216	GROUP ART UNIT 1765	ATTORNEY DOCKET NO. 10191/3399
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APPLICANTS

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\*\* CONTINUING DATA \*\*\*\*\* NONE

\*\* FOREIGN APPLICATIONS \*\*\*\*\* YES  
 GERMANY 102 49350.2 10/23/2002

IF REQUIRED, FOREIGN FILING LICENSE GRANTED  
 \*\* 01/22/2004

Foreign Priority claimed 35 USC 119 (a-d) conditions met	<input type="checkbox"/> yes <input checked="" type="checkbox"/> no <input type="checkbox"/> yes <input checked="" type="checkbox"/> no <input type="checkbox"/> Met after Allowance	STATE OR COUNTRY GERMANY	SHEETS DRAWING 9	TOTAL CLAIMS 5	INDEPENDENT CLAIMS 4
Verified and Acknowledged	Examiner's Signature <i>[Signature]</i> Initials <i>LV</i>				

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 26646  
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TITLE  
 Device and method for anisotropic plasma etching of a substrate, particularly a silicon element

FILING FEE  RECEIVED 986	FEES: Authority has been given in Paper No. _____ to charge/credit DEPOSIT ACCOUNT No. _____ for following:	<input type="checkbox"/> All Fees <input type="checkbox"/> 1.16 Fees ( Filing ) <input type="checkbox"/> 1.17 Fees ( Processing Ext. of time ) <input type="checkbox"/> 1.18 Fees ( Issue )
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